



PATENT
ATTY. DOCKET NO.: P68917US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of:

Cheol Hwan PARK, et al.

Serial No.: 10/600,332

Filed: June 23, 2003

For: METHOD FOR FORMING DEVICE ISOLATION FILM OF SEMICONDUCTOR DEVICE

Group Art Unit: 2812
Examiner: Stanetta D. Isaac

TRANSMITTAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an **Amendment Under Rule 1.116** for filing in the above-captioned patent application.

The fee has been calculated as shown below:

	Claims Remaining After Amendment	Highest Number Previously Paid For	Present Extra		Small Entity Rate Additional Fee	(or)	Other Than Small Entity Rate Additional Fee
Total Claims	11	- 20	=	x 25	= \$	x 50	= \$
Ind. Claims	01	- 03	=	x100	= \$	x200	= \$
<input checked="" type="checkbox"/> Multiple Dependent Claims				+180	= \$	+360	= \$
				Total	\$	Total	\$

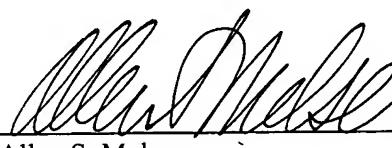
— A credit card payment form in the amount of \$0.00 is attached for:

XXXX If a Petition for Extension of Time is necessary and the Petition and/or the credit card payment form is not enclosed, this will act as the Petition and applicant herewith petitions the Commissioner to extend the time for response and charge any fees necessary under 37 CFR 1.17 (a)(1)-(5) to Deposit Account No. 06-1358. The Commissioner is also authorized to charge payment of any other additional fees associated with this communication or credit any overpayment to Deposit Account No. 06-1358. A duplicate copy of this sheet is attached.

Respectfully submitted,

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Date: May 6, 2005

ASM:SCB

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SEMICONDUCTOR DEVICE

AMENDMENT UNDER RULE 1.116

Commissioner for Patents
Mail Stop Amendment
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed February 9, 2005 (Paper No. 0105),
kindly amend the above-identified patent application as set forth herein.